



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

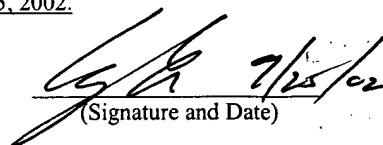
APPLICANT : Sung-Koog Oh                      Atty. Docket No: 5000-1-221  
SERIAL NO. : 09/981,940                      EXAMINER : Not yet assigned  
FILED : October 17, 2001                      ART UNIT : Not yet assigned  
FOR : METHOD FOR FABRICATING NICKEL ETCHING MASK

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(Signature and Date)

**TRANSMITTAL OF REVOCATION AND APPOINTMENT OF ATTORNEYS**

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

Dear Sir:

The undersigned, as an Applicant and owner hereof, hereby revokes all powers previously granted and appoints

**Steve S. Cha**

**Registration No. 44,069**

of CHA & REITER, 411 Hackensack Ave, 9th floor, Hackensack, New Jersey 07601, as new attorney with full power of substitution and revocation, to prosecute the above application, to make alterations and amendments therein, to receive the patent, and to transact all business in the Patent and Trademark Office connected herewith.

Please address any correspondence to

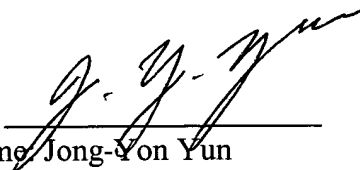
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and any telephone calls to Steve Cha, Esq., at (201) 518-5518.

Respectfully submitted,

Date: 9/10/02

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